



2822
Docket No. 0756-1551
H/M/KS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Info Patent Application of)

Art Unit: 2822

Shunpei YAMAZAKI et al.)

Examiner: M. Wilczewski

Serial No. 08/691,434)

Filed: August 2, 1996)

For: METHOD OF FABRICATING)

SEMICONDUCTOR DEVICES AND)

APPARATUS FOR PROCESSING A)

SEMICONDUCTOR)

CERTIFICATE OF MAILING

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[Signature]

**LETTER RESUBMITTING PETITION TO WITHDRAW
HOLDING OF ABANDONMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

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MAR 08 2004

Sir:

Applicant's representative contacted Examiner Wilczewski on March 1, 2004 regarding the status of the above-identified application. Examiner Wilczewski indicated that the *Petition to Withdraw Holding of Abandonment* filed by Applicant on June 25, 2003 was never received by the Patent Office. Enclosed herewith is a copy of the *Petition to Withdraw Holding of Abandonment*, a copy of the stamped receipt card evidencing receipt by the Patent Office on June 25, 2003. Also, enclosed are the documents attached to the *Petition to Withdraw Holding of Abandonment* including a copy of the formal drawings submitted by our draftsman, Quinn Patent Drawing Service, on February 25, 2003, along with the stamped acknowledgement from the Office of Patent Publication.

In view of the above and the enclosed documents herewith, it is believed that the *Notice of Abandonment* was issued in error. Therefore, it is respectfully requested that the *Notice of Abandonment* be rescinded.

Respectfully submitted,

[Signature]

Eric J. Robinson
Reg. No. 38,285
Robinson Intellectual Property Law Office, P.C.
PMB 955
21010 Southbank Street
Potomac Falls, Virginia 20165

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This will acknowledge receipt of the following:

1. Response to Notice of Abandonment (2 copies)
2. Copy of Notice of Abandonment
3. Copy of Formal Drawings and Stamped Receipt (2 copies)
4. Certificate of Mailing

In re PATENT application of:

SHUNPEI YAMAZAKI et al

Serial No. 08/691,434

Filed: 08/02/1996

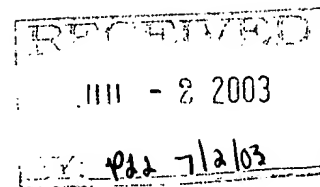
Due Date: 08/11/2003

For: METHOD OF FABRICATING SEMICONDUCTOR DEVICES AND APPARATUS FOR
PROCESSING A SEMICONDUCTOR

Docket: 0756-1551

June __, 2003

EJR/EJR/rmf





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Shunpei YAMAZAKI et al.)
Serial No. 08/691,434)
Filed: August 2, 1996)
For: METHOD OF FABRICATING)
SEMICONDUCTOR DEVICES AND)
APPARATUS FOR PROCESSING A)
SEMICONDUCTOR)

Art Unit: 2822

Examiner: M. Wilczewski

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Rose M. Sieber

PETITION TO WITHDRAW HOLDING OF ABANDONMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Applicant's representative received a *Notice of Abandonment* from the U.S. Patent Office mailed June 11, 2003 in the above-identified application. The *Notice of Abandonment* was issued due to "Applicant's failure to timely file new formal drawings as required in the Notice of Allowability."

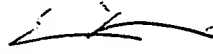
In response to the *Notice of Allowability* dated January 28, 2003, formal drawings were submitted by our draftsman, Quinn Patent Drawing Service, on February 25, 2003. Enclosed please find copies of the formal drawings along with the stamped acknowledgement from the Office of Patent Publication.

In view of the above and the enclosed documents herewith, it is believed that the *Notice of Abandonment* was issued in error. Therefore, it is respectfully requested that the *Notice of Abandonment* be rescinded.

Respectfully submitted,

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MAR 08 2004


Eric J. Robinson
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21010 Southbank Street
Potomac Falls, Virginia 20165
(571) 434-6789



REQUEST FOR PATENT DRAWING REVISIONS
(Please complete entire form)

QUINN PATENT DRAWING SERVICE
9200 Hampton Overlook
Capitol Heights, MD 20743

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MAR 08 2004

You are hereby authorized to correct the drawing(s) in the case indicated below:

- ☒ Correct informalities cited by Chief Draftsman (Include copy of Form #948)
- ☒ Enter changes approved by the Examiner (Include prints with changes marked in red)
- ☒ When double-line hatching or criss-cross hatching cited - advise correct hatching.

Special Instructions:

- ☐ Forward the formal drawings and file copies.
OR
☒ Forward a copy of changed drawings and notification of date refiled in USPTO to address below.
- ☒ A copy of the drawings as presently on file are enclosed for your use in making the required corrections.

ATTACH THE NOTICE OF ALLOWABILITY OR NOTICE OF ALLOWANCE

Name: Robinson Intellectual Property Law Office, P.C.
Address: PMB 955
21010 Southbank Street
Potomac Falls, Virginia 20165
Phone No. (571) 434-6789

Docket: 0756-1551

Date: 02/03/03

Corrected drawings due in USPTO no later than 04/28/03

NEW DRAWINGS


Please allow Quinn Patent Drawing Service to file the attached new drawing sheets for the ones originally filed.

Applicant Shunpei YAMAZAKI; Yasuhiko TAKEMURA; Akira TAKENOCHI

Serial No. 08/691,424 Filing Date 08/02/96

Title: Method of Fabricating Semiconductor Devices and Apparatus for Processing a Semiconductor

Date Allowed 01/28/03 Conf. No. 2240


Eric J. Robinson
Reg. No. 38,285

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FEB 25 2003

Office of Patent Publication
Director's Office

FIG. 1

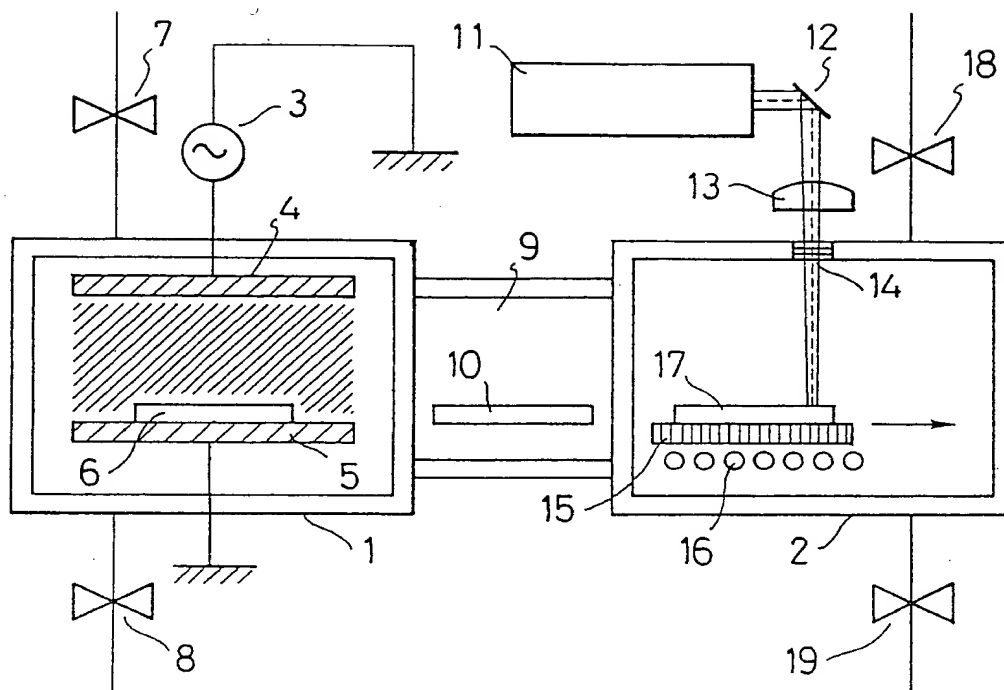


FIG. 2

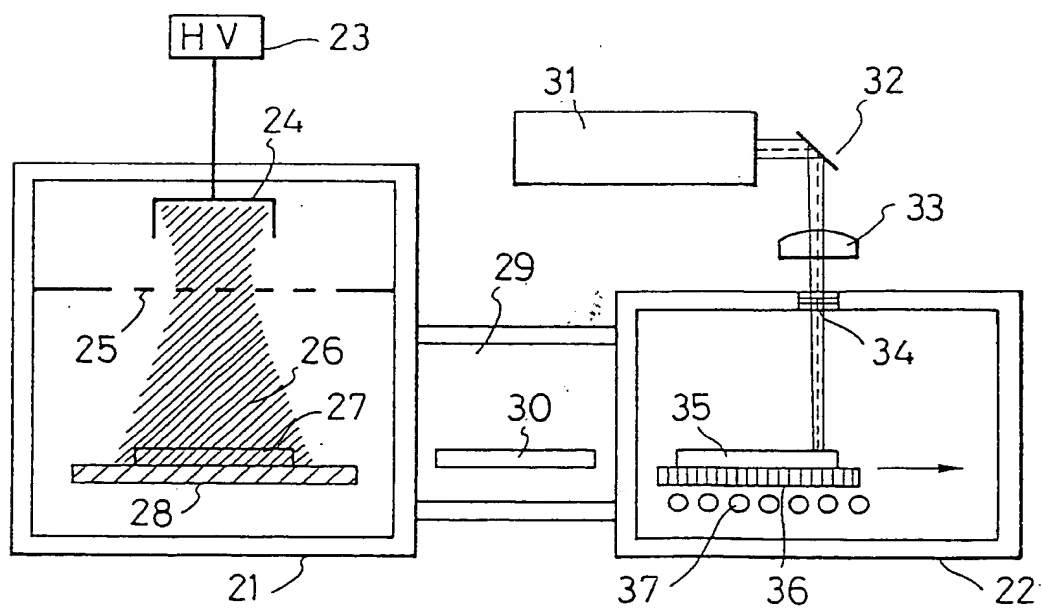


FIG. 3

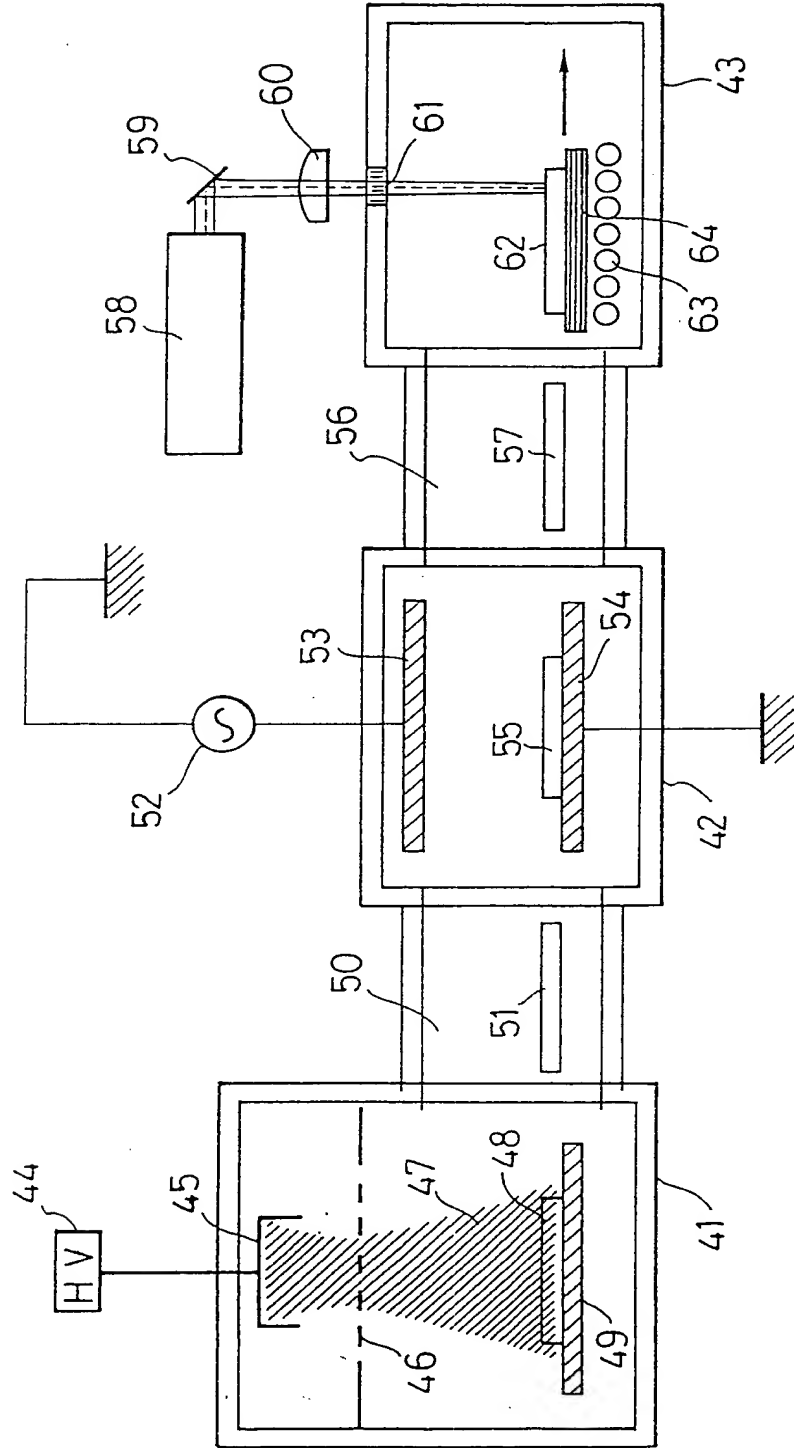


FIG. 4

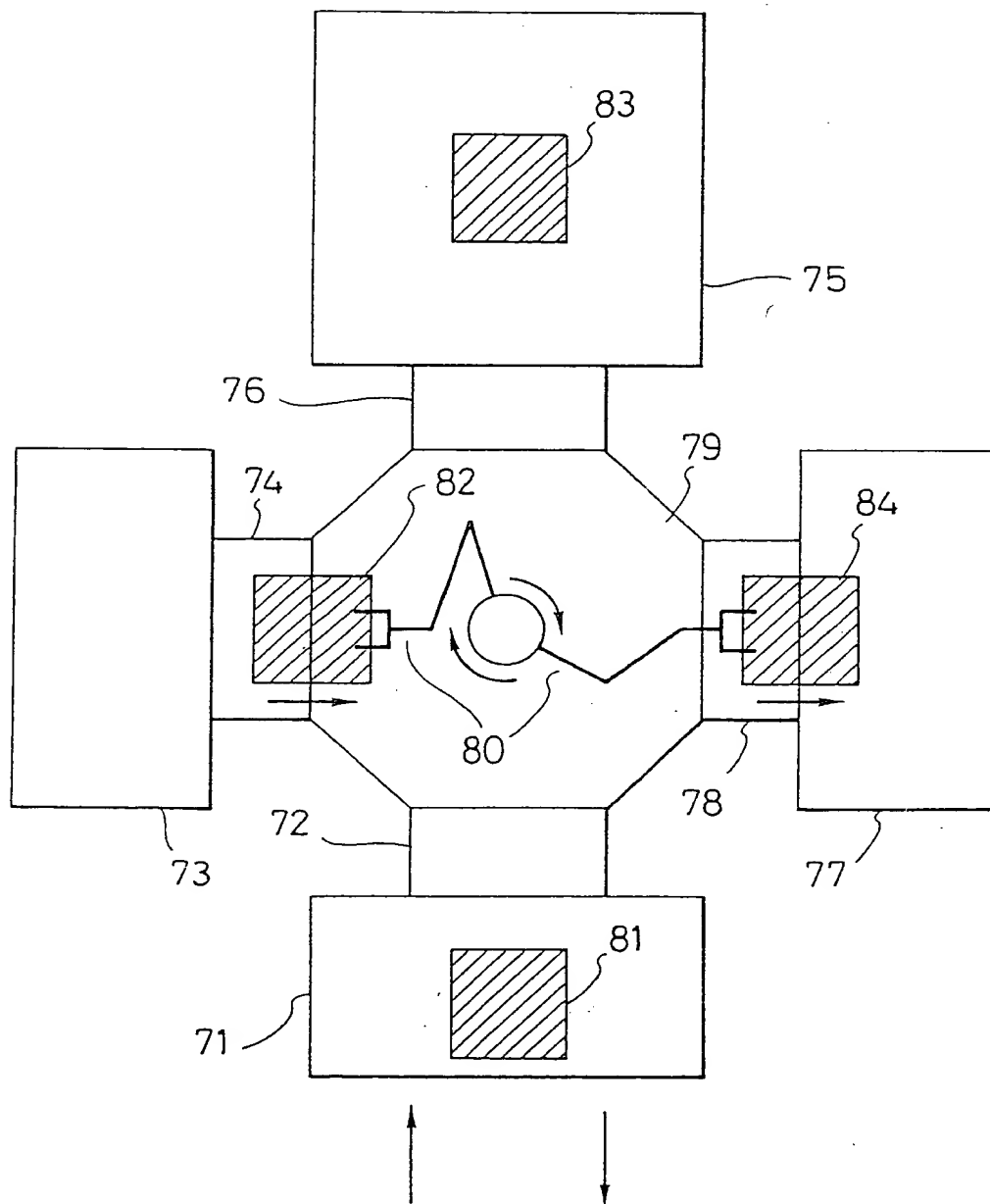


FIG. 5(A)

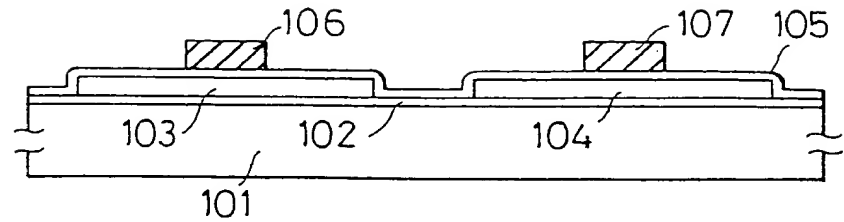


FIG. 5(B)

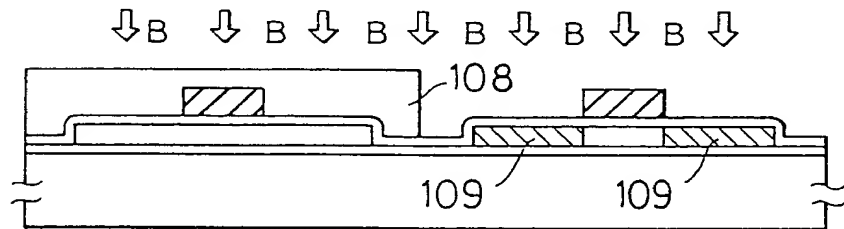


FIG. 5(C)

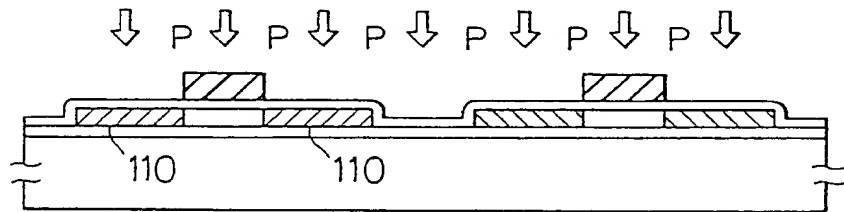


FIG. 5(D)

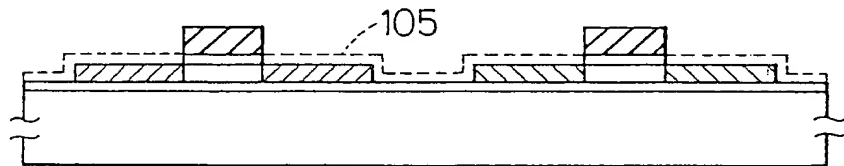


FIG. 5(E)

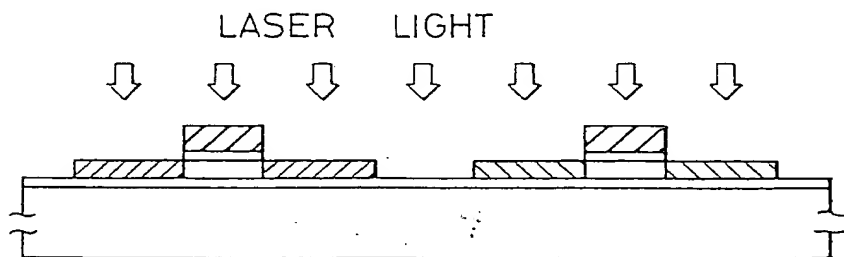


FIG. 5(F)

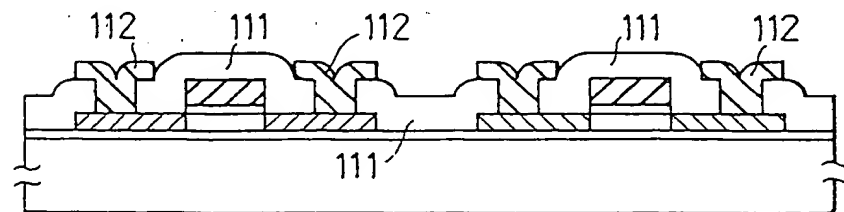


FIG. 6

